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SERIAL NUMBER 10/731,144	FILING DATE 12/10/2003  RULE	CLASS 438	GROUP ART UNIT 2823	ATTORNEY DOCKET NO. P69368US0	
<b>APPLICANTS</b> Sang Wook Ryu, Chungcheongbuk-Do, KOREA, REPUBLIC OF; ** CONTINUING DATA ***** None ** FOREIGN APPLICATIONS ***** T.D. REPUBLIC OF KOREA 2003-47630 07/12/2003 IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 03/11/2004					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>[Signature]</i> <i>[Initials]</i>		STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 2	TOTAL CLAIMS 11	INDEPENDENT CLAIMS 2
<b>ADDRESS</b> 00136 JACOBSON HOLMAN PLLC 400 SEVENTH STREET N.W. SUITE 600 WASHINGTON , DC 20004					
<b>TITLE</b> Method of forming trench in semiconductor device					
FILING FEE  RECEIVED 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		